OF JC109 HE JC109 HE

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group No.:

1753

Examiner:

Rodney McDonald

Docket No.

SA998141

For:

Filed:

In re Application of:

M. Pinarbasi

Serial No.:

SPIN VALVE SENSOR FREE LAYER STRUCTURE WITH A COBALT

BASED LAYER THAT PROMOTES MAGNETIC STABILITY AND

HIGH MAGNETORESISTANCE

RECEIVED

APR 1 5 2003

Assistant Commissioner for Patents Washington, D.C. 20231

09/458,581

12/09/99

TC 1700

Sir:

AMENDMENT

In response to the Office Action mailed 02/03/2003 please amend the application as follows:

In the drawings

A "Request for Drawing Amendment" accompanies this document.

Specification after amendment (see "Attachment" for present amendment)

Page 8, lines 16-17, the following three paragraphs are substituted:

Fig. 14 is a schematic illustration of an ion beam gun, target and substrate with the substrate rotated by angle α with respect to the target;

Fig. 15A is a perspective view looking from the right of and partially down on Fig. 14 with the ion beam gun enlarged and with the substrate rotated by angle β in addition to angle α ;

Fig. 15B is the same as Fig. 14 except the substrate has been rotated by angle β ;

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